Short

S.S.N. 10/072,798

MAR 0 8 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Tsai et al.

Group Art Unit: 1765

Serial No.: 10/072,798

Examiner: D. Nguyen

Filed: 02/07/2002

In Response to Office Action

Dated: 12/08/2003

For: A METHOD USING WET ETCHING TO TRIM A CRITICAL DIMENSION

Attorney Docket No.: 67,200-556

## Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Va 22313-1450

Date: Mar. 4/04

RESPONSE TO OFFICE ACTION

Commissioner for Patents P.O. Box 1450 Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 12/08/2003, please enter the following amendments and consider the following remarks.